

Substitute for form 1449A/PTO (modified)

Application Number

10/665,761

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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September 19, 2003

First Named Inventor

Jing, Naiyong

Art Unit

1733

Examiner Name

Attorney Case Number

56210US005

(Use as many sheets as necessary)

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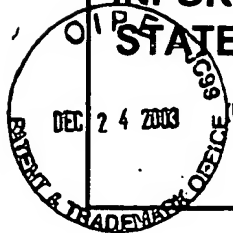
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	B2	JP	07-179628 ✓	07/18/1995			X Abstract only
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Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
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<i>JK</i>	C24	<u>Semiconductor International</u> , 11, Burggraf, Pieter, No. 8, Vol. 5, (1988)

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<i>PH</i>	A1	US- 6,752,894 B2	06/22/2004	Jing et al	

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